PTO/SB/08A (08-03) Approved for use through 07/31/2006. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known

Substitute for form 1449/PTO				_ L `	Complete ii Allouii			
1				Application Number				
INF	FORMATIO	N DISC	LOSURE	Filing Date				
	STATEMENT BY APPLICANT			First Named Inventor	Manchao Xiao	_		
	(Use as many sh	eets as nec	essary)	Art Unit				
				Examiner Name		_		
Sheet	4	of	2	. Attorney Docket Number	063777D HSA			

			U.S. PATENT DO	CUMENTS		
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or	
		Number-Kind Code ^{2 (F known)}			Relevant Figures Appear	
BC		^{US-} 6,350,708 B1	02/26/2002	Kelly T. Hurley		
		^{US-} 6,204,206 B1	03/20/2001	Kelly T. Hurley		
		^{US-} 6,127,287	10/03/2000	Kelly T. Hurley, et al		
		^{US-} 5,939,333	08/17/1999	Kelly T. Hurley, et al		
		^{US-} 6,365,231 B2	04/02/2002	Yuusuke Sato, et al		
		^{US-} 6,146,938	11/14/2000	Shigehiko Saida, et al		
		^{US-} 6,284,583 B1	09/04/2001	Shigehiko Saida, et al		
		^{US-} 5,976,991	11/02/1999	Ravi K. Laxman, et al		
		^{US-} 5,234,869	08/10/1993	Yuuichi Mikata, et al		
BC		^{US-} 5,874,368	02/23/1999	Ravi K. Laxman		
		US-				
		US-			W	
		US-				
		US-			<u></u>	
		US-				
		UŞ.			· · · · · · · · · · · · · · · · · · ·	

		FORE	GN PATENT D	OCUMENTS		
Examiner Initials*	Cite No.1	. Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Unes, Where Relevant Passages or	
	}	Country Code ³ Number ⁴ Kind Code ⁵ ff			Relevant Figures Appear	Τ ⁶
вс		JP 06132284(English abstract)	05/13/1994	Kawasaki Steel Corp		
 						

Examiner		Date	* * * * * * * * * * * * * * * * * * * *
Signature	/Bret Chen/	Considered	05/23/2006

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Ai xandria, VA 22313-1450.

Signature | Considered | Continue | Considered | Continue | Considered | Continue | Cont Translation is attached.

PTO/SB/088 (08-03)
Approved for use through 07/31/2008. OMB 0651-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO				Complete if Known		
		l DICOL	OCUBE	Application Number		
-	ORMATION			Filing Date		
317	(Use as many sheets as necessary)			First Named Inventor	Manchao Xiao	
				Art Unit		
				Examiner Name		
Sheet	2	of	3	Attorney Docket Number	06377ZP USA	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
вс		G.E. MCGUIRE, Semiconductor Materials and Process Technology Handbook, Noyes Publication, 1988, pp. 289-301.	
		STANLEY WOLF, Silicon Processing for the VLSI Era, Lattice Press, 1990, Vol. II, pp. 20-22; 327-331.	
		TETSUJI SORITA, Mass Spectrometric and Kinetic Study of Low-Pressure, J. Elect. Soc., 1994, Vol. 141, pp. 3505-3511.	
		B.A. SCOTT, Preparation of Silicon Nitride with Good Interface Properties, Chemtronics, 1989, Vol. 4, pp. 231-234.	
		J.M. GROW, Growth Kinetics and Characterization of Low Pressure, Elsevier Sci., 1995, Mat. Letters 23, pp. 187-193.	
		W.C. Yeh, Low-Temperature Chemical-Vapor-Deposition of Silicon-Nitride, J. Appl. Phys., 1996, Vol. 35, pp. 1509-1512.	
		ARTHUR K. HOCHBERG, Diethylsilane As A Silicon Source for the Deposition, Mat. Res. Soc. Symp., 1991, Vol. 204, pp. 509-514.	
		ROY G. GORDON, Silicon Dimethylamido Complexes and Ammonia, Chem. Mater. 1990, 2, pp. 480-482.	
		Z.I. SERGEEVA, Synthesis of Alkyl- and Dialkyl-Bis-(1,1-Dialkylhydrazino)-Silanes, J. Gen. Chem. of USSR, 1960, Vol. 30, pp. 716-717.	
		Z.I. SERGEEVA, Reaction of Unsymmetrical and Dialkylhydrazines, J. Gen. Chem. of USSR, 1963, 33, pp. 1823-1826.	
		MARCUS SOLDNER, Isomeric Cyclic Disilanedlyl Dimethylhydrazines, Inorg. Chem., 1998, 37, pp. 601-603.	
		NORBERT MITZEL, Two Different Cyclization Modes in the Formation of Silylhydrazines, Organometallics, 1993, 12, pp. 413-416.	
		NORBERT MITZEL, Cyclic Silylhydrazines and Their Borane Adducts, Inorg. Chem., 1995, 34, pp. 4840-4845.	
вс		SEIICHI TAKAMI, Monolayer Nitridation of Silicon Surfaces by A Dry Chemical, Appl. Phys. Lett., 1995, 66, (12) pp. 1527-1529.	

· Sheet 3 of 3

BC	DAVID R. LIDE, Handbook of Chem. and Physics, 81 st Edition, 2001, CRC Press, pp. 9-64-9-69.	

Examiner		Date	
- CVERIBLE!	4 4	Date	
Clamphum	/Bret Chen/	Considered (05/23/2006
Signature	,,	Considered	03/23/2000

EXAMINER: Initial if reference considered, whether or not citation is in conformation with MPEP 609. Draw line through citation if not in conformance and not

EXAMINER: Initial if reference considered, whether or not clauton is in conformation with MPEP 609. Draw line through citation in not in conformance and not considered. Include copy of this form with next communication to applicant. Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chef Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Pat nts, P.O. Box 1450, Alexandria, VA 22313-1450.
If you need assistance in completing the form, call 1-800-PTO-9199 (1-800-788-9199) and select option 2.

PTO/SB/08A (08-03)

Approved for use through 07/31/2008. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMB 0651-0031

The Paneround Reduction Act of 1995, so correspond to provide to record to a collection of information unless it contains a valid OMB control number.

TRADEN Sut	stitute for form 14	449/PTO	<u> </u>	Complete if Known		
· ·				Application Number	10/695,379	
INFO	RMATION	N DISCLOS	SURE	Filing Date	10/27/2003	
-		BY APPLIC	•	First Named Inventor	Manchao Xiao	
•	Use as many she	eets as necessai	v)	Art Unit	1762	
		Examiner Name				
Sheet	1	of	2	Attorney Docket Number	06377ZP USA	

			U. S. PATENT DO	DCUMENTS	
Examiner Initials*	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or
		Number-Kind Code ^{2 (II Incom)}			Relevant Figures Appear
		US-			
		US-			
		US-		· · · · · · · · · · · · · · · · · · ·	
		US-			
		US-			· · · · · · · · · · · · · · · · · ·
		US-			
		U\$-			
		US-			
	i	US-			· · · · · · · · · · · · · · · · · · ·
	_	US-			
		US-		· · · · · · · · · · · · · · · · · · ·	
		US-			

	FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or		
		Country Code ³ Number ⁴ Kind Code ⁵ (F			Relevant Figures Appear	T⁴	
BC		Abstract: JP 03 006566A	01/14/1991	Mitsubishi Electric Corp.		✓	
ВС		Abstract: JP 2000 080476 A	03/21/2000	Toshiba Corp.		*	
	ļ						

Examiner	/Prot Chan/	Date	05/02/0006
Signature	/Bret Chen/		1 05/23/2006
Signature		Considered	

Translation is attached.

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformation and not considered. Include copy of this form with next communication to applicant. ¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspio.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

PTO/SB/08B (08-03)
Approved for use through 07/31/2006. OMB 0851-0031
U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE o a collection of information unless it contains a valid OMB control number.

Substitute for form 1449/PTO				Complete if Known		
				Application Number	10/695,379	
STATEMENT BY APPLICANT				Filing Date	10/27/2003	
				First Named Inventor	Manchao Xiao	
(Use as many sheets as necessary)				Art Unit	1762	
				Examiner Name		
Sheet	2	of	2	Attorney Docket Number	06377ZP USA	

NON PATENT LITERATURE DOCUMENTS							
Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²					
	S.I. SERGEEVA, et al, "Synthesis of Alkyl-and dialkylbissilanes," Zhurnal Obshchei Khimii, 1960, P. 694-5, Vol. 30(2). ABSTRACT	1					
	M.G. VORONKOV, et al, "Silyl Derivatives of Asymmetric Dimethylhydrazine as a," Izvestiya Vysshikh Uchebnykh Zavedenii, 2002, P. 57-60, Vol. (4) ABSTRACT	1					
	·						
·							
·	•						
	Cite No. 1	Cite No. 1 Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. GEORGE GIBSON, et al, "Reaction of Silicon Tetrachloride With N,N-dimethylhydrazine and Hydrazin," Inorg. Chem., 1963, P. 876-8, Vol. 2(4). ABSTRACT S.I. SERGEEVA, et al, "Synthesis of Alkyl-and dialkylbissilanes," Zhurnal Obshchei Khimii, 1960, P. 694-5, Vol. 30(2). ABSTRACT M.G. VORONKOV, et al, "Silyl Derivatives of Asymmetric Dimethylhydrazine as a"					

Examiner	/Bret Chen/	Date	05/23/2006
Signature	/Bret Chen/	Considered	05/23/2006

*EXAMINER: Initial if reference considered, whether or not citation is in conformation with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

'Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office,